## CLAIMS

- 1. A diamond-coated silicon comprising a silicon substrate having a thickness of 500  $\mu m$  or less coated at least partially with electrically conductive diamond.
- An electrode, comprising an electrically conductive support substrate and the diamond-coated silicon according to claim 1.
- 3. The electrode according to claim 2, wherein at least one portion of the electrically conductive support substrate is bonded to the diamond-coated silicon.
- 4. The electrode according to claim 2, wherein at least one surface of the electrically conductive support substrate is bonded to the diamond-coated silicon.
- 5. The electrode according to claim 3 or 4, wherein the electrically conductive support substrate is bonded to the diamond-coated silicon with an electrically conductive bonding material.
- 6. The electrode according to any one of claims 3 to5, wherein the bonding is performed by welding or adhesion.